

Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 111594		APPLICATION NO. 10/026,653	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICANT(S) Masaya ISHIDA et al.			
				FILING DATE December 27, 2001		GROUP <b>1754</b>	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
<b>ny</b>		5,079,600	01/07/92	SCHNUR et al.	<b>357</b>	<b>4</b>	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
<b>ny</b>		DRESSICK, Walter J. et al., "Patterning of Self-Assembled Films Using Lithographic Exposure Tools", <i>Jpn. J. Appl. Phys.</i> , Vol. 32 (1993), pp. 5829-5839.					
EXAMINER <b>Wickham</b>				DATE CONSIDERED <b>3/19/04</b>			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: April 26, 2002